IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Takashi OHSAKO et al.

Serial No. 10/677,221

Filed October 3, 2003

OIPE SEP US 2005

Confirmation No. 8585

Docket No. 2003_1364A

Group Art Unit 2823

Examiner Joannie Garcia

METHOD OF MANUFACTURING SEMICONDUCTOR ELEMENT

ADDITIONAL CLAIMS FEE TRANSMITTAL LETTER

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT ACCOUNT NO. 23-0975

Sir:

Transmitted herewith is an Amendment in the above-identified application. Additional fees required as a result of this Amendment are calculated as follows:

	SMALL ENTITY		LARGE ENTITY
Total Claims exceeding 20 (not already paid for): 5 x Indep. Claims exceeding 3	(\$ 25 = \$)	or	(\$50 = \$250.00)
(not already paid for): 1 x	(\$100 = \$)	or	(\$200 = \$200.00)
Total Additional Fee =	<u>\$</u>	or	<u>\$450.00</u>

[X] A check in the amount of \$450.00 is enclosed.

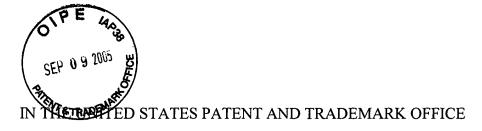
Respectfully submitted

Takashi OHSAKC

W. Douglas Hahm

Registration No. 44,142 Attorney for Applicants

WDH/ck Washington, D.C. 20006-1021 Telephone (202) 721-8200 Facsimile (202) 721-8250 September 9, 2005



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<u>AMENDMENT</u>

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT ACCOUNT NO. 23-0975

Sir:

Responsive to the Office Action dated March 9, 2005, the period for response to which having been extended by three months to September 9, 2005, please amend the above-identified application as follows.

09/12/2005 JADD01 00000008 10677221

02 FC:1201 03 FC:1202

200.00 OP 250.00 OP